



Application No. 10/600,596
Docket No. 740819-1016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Satoshi SHIBATA et al.)
Serial No. 10/600,596)
Filed: June 23, 2003)
For: METHOD FOR PREDICTING)
TEMPERATURE, TEST WAFER)
FOR USE IN TEMPERATURE)
PREDICTION, AND METHOD)
FOR EVALUATING LAMP HEATING)
SYSTEM)

Examiner: Stanley J. Pruchnic
Group Art Unit: 2859
Confirmation No. 6775

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The undersigned certifies that either (1) each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in connection with a counterpart foreign application not more than three (3) months prior to the filing of this statement, or (2) no item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application and to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this statement.

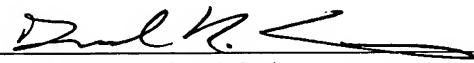
Enclosed is a copy of a Notice of Reasons of Rejection dated December 9, 2003, for the corresponding Japanese Patent Application.

Please note that cited reference JP 2000-232142, is equivalent to U.S. 6,475,815 and WO98/57146, were previously filed in the USPTO on June 23, 2003, therefore these references are not enclosed.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380. (740819-1016)

Respectfully submitted,

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Substitute for form 1449A/PTO				<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/600,596
Sheet	1	of	1	Filing Date	June 23, 2003
				First Named Inventor	Satoshi SHIBATA
				Art Unit	2859
				Examiner Name	Stanley J. Pruchnic
				Attorney Docket Number	740819-1016

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-			

FOREIGN PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Kind Cod (if known) Country Code ³ Number ⁴			
		JP 03-079057	04-04-1991	Onishi	Abstract
		JP 07-248264	09-26-1995	McArthur et al.	Abstract
		JP 07-294569	11-10-1995	Harada et al.	Abstract
		JP 09-320988	12-12-1997	Fuji et al.	Abstract and Partial Translation
		JP 11-160166	06-18-1999	Tanaka	Abstract and Partial Translation

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
		NOTICE OF REASONS OF REJECTION DATED DECEMBER 9, 2003			

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.